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CONFIRMATION NO. 2217

SERIAL NUMBER 10/609,476	FILING DATE 07/01/2003 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. Q76291	
APPLICANTS Hirofumi Fujioka, Tokyo, JAPAN; Kenichi Koyanagi, Tokyo, JAPAN; <i>Hirofumi Kitamura, Tokyo, JAPAN</i> ** CONTINUING DATA ***** <i>None & W.S.</i> ** FOREIGN APPLICATIONS ***** <i>& W.S.</i> JAPAN 194006/2002 07/02/2002 IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/29/2003					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met <i>allowance</i> Verified and <i>& W.S.</i> Acknowledged Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 35	INDEPENDENT CLAIMS 3
ADDRESS 23373 SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037					
TITLE METHOD FOR SEMICONDUCTOR DEVICE MANUFACTURING TO INCLUDE MULTISTAGE CHEMICAL VAPOR DEPOSITION OF MATERIAL OXIDE FILM					
FILING FEE RECEIVED 1320	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		